



Contribution ID: 874

Type: not specified

4MP5-14 Microstructure and superconducting properties of impurity doped Bi,Pb-2223 thin films fabricated sputtering method

Thursday 21 September 2017 10:26 (1 minute)

Author: MATSUMOTO , Akiyoshi (National Institute for Materials Science)

Presenter: MATSUMOTO , Akiyoshi (National Institute for Materials Science)

Session Classification: Poster : 4MP5 - Cuprate Thin Films 2/2